

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	6	("4606151" "6179956" "6315634" "6354928" "6436828" "6725120").PN.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/25 13:15
S2	0	"6436828".URPN.	USPAT	OR	OFF	2004/10/25 11:46
S3	28	("1665226" "2443733" "2474800" "4222204" "4270314" "4873792" "4941245" "5205082" "5357717" "5398459" "5441444" "5443416" "5498199" "5624299" "5643053" "5681215" "5732938" "5828224" "5940956" "5989103" "6019671" "6036587" "6059638" "6121142" "6121143" "6183352" "6188544" "6220945").PN.	USPAT	OR	OFF	2004/10/25 11:46
S4	4790	polishing with (magnet magnets magnetic)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/25 13:15
S5	1082	S4 and (semiconductor semiconductors (integrated adj (circuit circuits)) wafer wafers)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/25 13:16
S6	456	S4 same (semiconductor semiconductors (integrated adj (circuit circuits)) wafer wafers)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/25 13:17
S7	37	S6 same (pressure pressurization)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/25 13:17
S8	50	156/345.14.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/25 11:43
S9	6	US-5432395-\$ DID. OR US-6028669-\$ DID. OR US-6050878-\$ DID. OR US-6050882-\$ DID. OR US-6056632-\$ DID. OR US-6059638-\$ DID.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/05/05 11:13
S10	1165	451/288.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:56
S11	1865	451/285-287.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:57
S12	244	(451/288.ccls. 451/285-287.ccls.) and (magnet magnets magnetic magnetically)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/05/05 15:21

S13	6	brown-nathan-r.in.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:54
S14	244	(451/288.ccls. 451/285-287.ccls.) and (different differential) with (pressure pressures)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/05/10 11:53
S15	18	("5205082" "5230184" "5584746" "5584751" "5605488" "5624299" "5660517" "5681215" "5738574" "5762539" "5762544" "5762546" "5795215" "5820448" "5941758" "5964653" "6361419" "6390905").PN.	USPAT	OR	OFF	2004/05/05 15:26
S17	219	((different differential independent independently) with (pressure pressures pressurization) same (actuate actuates actuators)) and (wafer wafers semiconductor semiconductors)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/05/10 11:56
S18	12	((different differential independent independently) with (pressure pressures pressurization) same (actuate actuates actuators)) and (wafer wafers semiconductor semiconductors)) and (metrology metrological)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/05/10 11:56
S19	3077	(pressure pressures pressurization) with (actuate actuators actuates control controls controller controllers sensor sensors) and "451"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:44
S20	161	(pressure pressures pressurization) with (actuate actuators actuates control controls controller controllers sensor sensors) with (plural plurality) and "451"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:52
S21	10	((pressure pressures pressurization) with (actuate actuators actuates control controls controller controllers sensor sensors) with (plural plurality) and "451"/\$.ccls.) and (metrology metrologic metrological)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:52
S22	83	((pressure pressures pressurization) with (actuate actuators actuates control controls controller controllers sensor sensors) and "451"/\$.ccls.) and (metrology metrologic metrological)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:49

S23	178	(pressure pressures pressurization) with (actuate actuators actuates control controls controller controllers sensor sensors) with (plural plurality) and "156"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:52
S24	4	((pressure pressures pressurization) with (actuate actuators actuates control controls controller controllers sensor sensors) with (plural plurality) and "156"/\$.ccls.) and (metrology metrologic metrological)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:53
S25	5415	(different differential independent independently) with (pressure pressures pressurization) same (actuate actuates actuators)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:53
S26	22	((different differential independent independently) with (pressure pressures pressurization) same (actuate actuates actuators)) and (metrology metrologic metrological)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 19:00
S27	10	brown-nathan-r.in.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:54
S28	56	156/345.14.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:55
S29	1208	451/288.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:57
S30	1963	451/285-287.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 07:56
S31	71	(156/345.14.ccls. 451/288.ccls. 451/285-287.ccls.) and (metrology metrologic metrological)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:59
S32	44121	(independent independently) with (pressure pressures pressurization)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 18:59
S33	126	((independent independently) with (pressure pressures pressurization)) and (metrology metrologic metrological)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 19:00
S34	62	(((independent independently) with (pressure pressures pressurization)) and (metrology metrologic metrological)) and (polish polishes polishing planarize planarizes planarization)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/10/22 19:00

S35	1971	451/285-287.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 07:58
S36	5422	(different differential independent independently) with (pressure pressures pressurization) same (actuate actuates actuators)	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 07:57
S37	5	S35 and S36	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 07:57
S38	1212	451/288.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 07:59
S39	6	S36 and S38	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 07:58
S40	44	"451"/\$.ccls. and S36	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 09:19
S41	38	"156"/\$.ccls. and S36	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 09:22
S42	11	"438"/\$.ccls. and S36	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 09:23
S43	4	"216"/\$.ccls. and S36	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2004/11/04 09:23